



IFW

PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: SMITHER, Robert K.  
Application: HIGH SPATIAL RESOLUTION X-RAY GAMMA RAY IMAGING  
SYSTEM USING CRYSTAL DIFFRACTION LENSES  
Serial Number: 10/775,789  
Filing Date: February 10, 2004  
Art Unit: 2882  
Examiner: KAO, Chih Cheng G.  
Atty. Docket: 0003/01475

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail, pursuant to 37 C.F.R. § 1.8 addressed to: Mail Stop: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on 7/29/2005 (Date of Deposit).

Heather Cruz-Santiago  
Name of Representative

Heather Cruz-Santiago  
Signature

7/29/05  
Date of Signature

Mail Stop: Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

20 N. Wacker Dr.  
Chicago, IL 60606  
312-621-1330

LETTER TO THE OFFICIAL DRAFTSPERSON

Dear Sir or Madam:

In response to the May 3, 2005, Office Action transmitted herewith are eight sheets of annotated and replacement drawings for figures 5a-5b, 6, 7, 13-14, and 15a-15b. Applicant hereby submits said drawing as replacement sheets to rectify the May 3, 2005 objections made by the Examiner.

No new matter has been added to this formal drawing.

Respectfully submitted,

CHERSKOV & FLAYNIK

By Michael J. Cherskov  
Michael J. Cherskov (Reg. No 33,664)